

## VOLUME 2

## SECTION XV

## SYMPOSIUM

## VACUUM METALLURGY

## (INVITED PAPERS)

	<i>Page</i>
High-Power-Density Electron Beam Welding of Several Materials — J. W. Meier . . . .	670
Fusion Welding of Beryllium in a Vacuum Atmosphere—W. T. Hess, H. J. Lander, S. S. White and L. McD. Schetky . . . . .	679
The Electron Beam Welding of Refractory Metals — H. J. Lander, W. T. Hess, R. Bakish and S. S. White . . . . .	685
Studies on Electron Beam Welding — G. Ito, H. Suzuki, T. Hashimoto and F. Matsuda	693
Electron Beam Processes at Different Voltages — H. Schwarz . . . . .	699
The Megawatt Class Electron Beam Melting and Casting Furnace — H. R. Smith, Jr., C. d'A. Hunt and C. W. Hanks . . . . .	708
Experience with an Electron Beam Melting Furnace — C. B. Sibley and M. L. Torti	714
Electron Beam Melting with Multiple Guns — H. Gruber, H. Stephan, W. Dietrich and R. Lesser . . . . .	722
Melt Stock Cathode for Low Voltage Vacuum Melting Furnace — J. W. Griffith, W. A. Prothero and J. C. Mutton . . . . .	732
A Gas-Cooled Vacuum Arc Skull Furnace — N. Beecher and J. L. Ham . . . . .	737
A Skull Furnace and Its Operation — C. Hayashi, S. Kashu and T. Tsuchiya . . . . .	744
Determination of Composition and Pressure of Gases over the Melt in a Vacuum Arc Furnace — E. W. Johnson, R. Itoh, R. L. Readal and M. L. Hill . . . . .	749
Production Experience with a 5000 Pound Vacuum Induction Furnace — W. A. Matejka	757
Studies on Vacuum Induction-Melting of Iron and Nickel — K. Muramatsu . . . . .	765
High Capacity Vacuum Fusion Apparatus for Gas Determinations in Chromium— A. Lench and G. S. Martin . . . . .	776
A New Vacuum Fusion Analyser for High Purity Metals — R. Lesser . . . . .	782
Vacuum Hot Pressing of Refractory Materials — E. W. Hoyt . . . . .	788
A New Continuous Vacuum Furnace for Metal-Strip Treatment — F. Krall, W. Scheibe and G. Ogiermann . . . . .	791

## VOLUME 2

	<i>Page</i>
Anwendung der Hochvakuum-Technik zur Herstellung von Halbleitereinkristallen und Transistoren — O. Korn .....	795
Brazing of Sandwich Structures of Columbium Alloys — M. M. Schwartz .....	805

## SECTION XVI

## ELECTRON BEAM MELTING AND GAS EVOLUTION

## (CONTRIBUTED PAPERS)

Automatic Apparatus for Measuring Gas Evolution Rates — M. L. Hill .....	813
Contribution to the Problem of Electron Beam Design for Melting, Welding, Evaporation and Drilling Processes — E. B. Bas, G. Cremosnik and H. Lerch .....	817

## SECTION XVII

## THIN FILMS; PRODUCTION, MEASUREMENT AND THEIR PROPERTIES

## (CONTRIBUTED PAPERS)

A Method for Detecting Imperfections in Thin Insulating Films — E. M. DaSilva and P. White .....	830
A Stylus Method for Evaluating the Thickness of Thin Films and Substrate Surface Roughness — N. Schwartz and R. Brown .....	836
Thickness Determination of Thick Films with Multiple-Beam Interferometry — S. J. Lins .....	846
Instrument for the Controlled Deposition of Optical Film Systems — W. Steckelmacher and J. English .....	852
Multilayered Thin Film Capacitors — H. J. Degenhart and I. H. Pratt .....	859
Properties of Thin Nickel-Chromium Films — T. K. Lakshmanan .....	868
Some Properties of Evaporated Refractory Metal Films — N. J. Maskalick and C. W. Lewis .....	874
Electrical Properties of Metal-Dielectric Films — W. J. Ostrander and C. W. Lewis ..	881
Properties of Evaporated Silver Films — R. T. Galla, R. F. Hoeckelman and C. C. Matle ..	889
Vacuum Deposition of Ductile Metallic Films — W. F. Brunner and H. G. Patton ...	895
Vacuum Evaporated Silicon Films — F. M. Collins .....	899

## VOLUME 2

	<i>Page</i>
The Electrical and Structural Properties of Dielectric Metal Mixtures — M. Beckerman and R. E. Thun .....	905
The Influence of the Deposition Parameters on the Properties of Evaporated Thin Ferromagnetic Films — K. H. Behrndt .....	912
Study of the Magnetization of Ultrathin, Evaporated Nickel Films in a Changing Environment — C. A. Neugebauer .....	924
Preparation and Magnetic Anisotropy of Continuous, Single Crystal Nickel Films— J. C. Anderson .....	930
Stress and Stress Anisotropy in Iron Films —J. D. Finegan and R. W. Hoffman .....	935
Stresses in Evaporated Dielectric Films—H. Blackburn and D. S. Campbell .....	943
Residual Stress in Silicon Monoxide Films —J. Priest and H. L. Caswell .....	947
Combined Evaporator and Electron Diffraction Apparatus for the Study of Epitaxial Growth—G. G. Via and R. E. Thun .....	950
Production of Monocrystalline Germanium Films by Electron Beam Evaporation in Ultra-High Vacuum and Their Electrical Properties—W. Reichelt and G.F.P. Müller ...	956
Etude de la Variation en Cours d'Evaporation de Propriétés Diélectriques de Composés Semiconducteurs Application au Moyen d'un Appareil pour Evaporations Multiples sous Haut Vide — R. Guillien, G. Marchal and S. Roizen .....	965
Evaporated Integrated Microcircuitry for Electronic Systems—D. W. Moore .....	976
The Deposition of Composite Passive Micro-Miniature Circuits by Vacuum Evaporation—K. Taylor .....	981
A New Deposition Technique for Refractory Metal Films—M. S. P. Lucas, C. R. Vail, W. C. Stewart and H. A. Owen .....	988
Production of Thin Self-Supporting Carbon Films — B. J. Massey .....	992
Coating Technique in Ultra-High Vacuum—J. Th. Moll .....	995
In Situ X-Ray Diffraction Studies of Thin Film Formation—F. Schossberger and F. Ticulka	1001
Tracer Studies of Vapor-Deposited ZnS:Ag, Cl Phosphor Films—J. K. Lee .....	1006
Electron Microscopy of Glass and Quartz Substrate Surfaces for Thin Films—C. J. Calbick	1013

## SECTION XVIII

## VAPORIZING SOURCES AND LYOPHILIZATION

## (CONTRIBUTED PAPERS)

A Continuously-Fed Electron Bombarded Source for the Evaporation of Alloys Containing Nickel, Iron or Cobalt—G. Siddall and B. A. Probyn .....	1017
--	------

## VOLUME 2

	<i>Page</i>
Etude et Réalisation d'un Nouveau Canon à Electrons Adapté à l'Evaporation des Corps Sous Vide—P. Duval .....	1022
An Evaporation Rate Control System Employing a Heated Electrode Sensing Gauge— M. H. Perkins .....	1025
The Influence of Alternating Current on the Evaporation of Tungsten Filaments in Vacuum —A. Roth .....	1031
Filament Arrangements for Film Thickness Uniformity in Vacuum-Deposited Thin Mag- netic Films—J. H. Engelman .....	1036
Eine Theoretische Methode zur Berechnung von Einfachwendeln für Gasgefüllte Elektrische Glühlampen—R. Kövesligethy .....	1042
The Application of Liquid Metal Circulating Systems in Vacuum Technology— E. I. Fazekas .....	1047
Evaporation of a Large Amount of Aluminum — Y. Moriya, N. Okuma and K. Sugiura	1055
Expériences Nouvelles sur la Lyophilisation—J. M. Dunoyer et J. Larousse .....	1059
Vapor Phase Conditions in Freeze-Drying—J. D. Mellor .....	1064
Wärmeübertragung und Temperaturkontrolle beim CQC-Gefriertrocknungsprozess— H. Ehlers, U. Hackenberg und G. W. Oetjen .....	1069
Hochvakuum-Trocken- und Imprägnieranlage für Hochspannungskabel für Spannungen bis zu 500 kV—M. Beyer and W. Reulecke .....	1073

## SECTION XIX

## LEAKS AND GAS FLOW

## (CONTRIBUTED PAPERS)

High Sensitivity Helium Mass Spectrometer Leak Detection—M. Doctoroff, S. S. Grossel and D. W. Oblas .....	1081
Standard Leaks and Their Calibration by Constant Pressure Change in Volume Techniques—M. K. Laufer .....	1086
Correlations Between Leak Rate and Some Phenomena Observed in Metal-to-Metal Contact—G. Armand, J. Lapujoulade and J. Paigne .....	1091
Production Leak Testing of Large Pressure Vessels—J. G. King .....	1100
Degradation of Glass Vacuum Tubes as a Result of Helium Permeation—J. J. Rode .....	1106

## VOLUME 2

	<i>Page</i>
Molekulare Strömung bei sehr Niedrigen Drucken—H. L. Eschbach, R. Jaeckel und D. Müller .....	1110
Vacuum Flow of Gases Through Channels with Circular, Annular, and Rectangular Cross Sections—W. Dong and L. A. Bromley .....	1116

## SECTION XX

## VACUUM SYSTEMS

(CONTRIBUTED PAPERS)

Ring Vacuum System Zero Gradient Synchrotron Argonne National Laboratory—J. Moenich and R. Treka .....	1133
Ring Magnet Vacuum Chamber System of the Argonne National Laboratory Zero Gradient Synchrotron —W. B. Hanson .....	1140
Ultra High Vacuum System for a Large Electromagnetic Isotope Separator—R. J. Connor, R. S. Buritz and T. von Zweck .....	1151
Experience with the Vacuum Equipment for the CERN 25 GeV Proton-Synchrotron—G. L. Munday and G. Zinsmeister .....	1154
Ultra-High-Vacuum Pump Sets—H. Adam and K. H. Mirgel .....	1158
A Portable, High-Speed Ultra High Vacuum System—R. E. Honig .....	1166
Experiences with Demountable Ultra-High Vacuum Systems—B. D. Power and R. F. Robson .....	1175
An Ultra-High Vacuum System for Low Energy Electron Diffraction Studies—J. Morrison	1183
A Large Differential Pumping System—P. Shapiro .....	1186
Dynamic Pressure Stages for High-Pressure/High-Vacuum Systems—B. W. Schumacher	1192
A Low Pressure Evaporation Plant for Rapid Operation—L. Holland and S. K. Bateman	1201
Performance of a Double-Walled UHV Chamber—R. A. Metcalfe and F. W. Trabert	1211
Aspects of the Technology of Mercury Vapor Pumping Systems—B. D. Power, N. T. M. Dennis and D. J. Crawley .....	1218
UHV-Controlled Atmosphere Test Chamber Using Mercury Vapor Pump Sets—P. J. Bryant and C. M. Gosselin .....	1224

## VOLUME 2

## SECTION XXI

## SPACE SIMULATION

(CONTRIBUTED PAPERS)

	<i>Page</i>
Design and Operating Criteria for Environmental Vacuum Chambers—D. C. Spence..	1228
Evacuating Large Space Chambers with Positive Displacement Blowers— D. L. Dowling, D. B. Herrick and W. E. Rose .....	1235
Materials Evaluation under High Vacuum and Other Satellite Environmental Conditions— P. H. Blackmon, F. J. Clauss, C. E. Ledger and R. E. Mauri .....	1244
A High-Vacuum Orbital Simulator—W. G. Camack and C. A. Ellis .....	1260
Space Thermal Environment Simulation Facilities—A. D. LeVantine .....	1270
Application of Liquid-Helium Cryopumping to Large Electric Rocket Vacuum Facilities— R. J. Cybulski, E. A. Richley and T. A. Keller.....	1279
Experimental Evaluation of High-Vacuum Condensers in Large Vacuum Facilities— E. A. Richley, R. J. Cybulski and T. A. Keller .....	1285
Biomedical Safety Provisions for Aerospace Environment Facilities—W. L. Lee, Jr. ...	1292

## SECTION XXII

## COMPONENTS, REFRIGERATION AND BAFFLING

(CONTRIBUTED PAPERS)

High and Low Temperature Vacuum Seals—K. S. Balain .....	1300
New Developments in Vacuum Sealing -- J. R. Jordan .....	1302
Ultra-High Vacuum Flanges — W. R. Wheeler and M. Carlson.....	1309
Metal-to-Metal and Ceramics-to-Metal Bakeable Vacuum Seals — G. Comşa, S. Lungu and C. Simionescu .....	1319
Commercial Seals as Seats in a Bakeable Valve — J. R. Ullman .....	1323
A Circulating Liquid-Nitrogen-Cooled Baffle for Ultra-High Vacuum Systems — A. R. Taylor .....	1328
Desorption Experiments under Ultra-High Vacuum Conditions at Low Temperatures -- J. Hengevoss and W. K. Huber .....	1332
Design and Operation of a Two Refrigerant, Two Stage Refrigerating Unit to Produce Temperatures of $-130^{\circ}\text{C}$ and Its Use on Low Temperature Oil Traps — R. Servranckx	1338
An Efficient In-Line Combination Liquid Nitrogen Cold Trap and Refrigerated Baffle for Use on Mercury Pumped Ultra-High Vacuum Systems — T. Foote and D. Damoth .	1343
Mechanism and Properties of a New Device to Reduce Back-Streaming of Hydrocarbon Molecules — R. A. Haefer .....	1346